

BIAS-INDEPENDENT CAPACITOR BASED ON SUPERPOSITION OF NONLINEAR CAPACITORS FOR ANALOG/RF CIRCUIT APPLICATIONS

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BACKGROUND OF THE INVENTION

Field of the Invention

[0001] The present invention is related to capacitors used in integrated circuits, and more particularly, to linear capacitors for use in analog and RF circuits.

Related Art

[0002] In analog/RF integrated circuits, bias-voltage-independent capacitors are needed to achieve high linearity of circuit performance. However, the bias-voltage-independent capacitors, such as fringe capacitors (made by sidewalling of metal lines), MIM (metal-insulator-metal) capacitors, or poly-oxide-poly capacitors are fairly expensive. These types of capacitors require a large surface area or additional processing steps, leading to higher manufacturing costs. On the other hand, MOSFET-type capacitors have the highest capacitance per unit area, since they are formed by thin gate-oxide, but their capacitance value is dependent on the gate/pickup terminals voltage, and is often non-linear.

[0003] Traditionally, circuit designers have chosen Metal-insulator-Metal (MIM) or Poly-insulator-Poly (PIP) based capacitors for bias-independent linear capacitors. However these types of capacitor require a larger area and sometimes require additional fabrication processing steps leading to higher manufacturing costs.

SUMMARY OF THE INVENTION

[0004] The present invention is directed to a bias-independent capacitor based on superposition of nonlinear capacitors for analog/RF circuit applications that substantially obviates one or more of the problems and disadvantages of the related art.

[0005] An embodiment of the present invention includes a first MOS-on-NWELL device formed on a substrate with its pickup terminals optionally connected together. A second MOS-on-NWELL device is formed on the substrate with its pickup terminals optionally connected together. A gate of the first MOS-on-NWELL device is connected to the pickup terminals of the second MOS-on-NWELL device. A gate of the second MOS-on-NWELL device is connected to the pickup terminals of the first MOS-on-NWELL device. A first PMOS transistor is formed on the substrate with its source and drain terminals connected together. A second PMOS transistor is formed on a substrate with its source and drain terminals connected together. A gate of the first PMOS transistor is connected to the source and drain terminals of the second PMOS transistor. A gate of the second PMOS transistor is connected to the source and drain terminals of the first PMOS transistor. A combination of the first and second PMOS transistors are connected in parallel with the first and second MOS-on-NWELL devices.

[0006] Additional features and advantages of the invention will be set forth in the description that follows, and in part will be apparent from the description, or may be learned by practice of the invention. The advantages of the invention will be realized and attained by the structure and particularly pointed out in the written description and claims hereof as well as the appended drawings.

[0007] It is to be understood that both the foregoing general description and the following detailed description are exemplary and explanatory and are intended to provide further explanation of the invention as claimed.

BRIEF DESCRIPTION OF THE DRAWINGS

[0008] The accompanying drawings, which are included to illustrate exemplary embodiments of the invention and are incorporated in and constitute a part of this specification, illustrate embodiments of the invention and together with the description serve to explain the principles of the invention. In the drawings:

[0009] FIG. 1A illustrates a MOS-on-NWELL device that may be used as a capacitor.

- [0010] FIG. 1B illustrates a single MOS-on-NWELL device connected to function as a capacitor.
- [0011] FIG. 1C illustrates a capacitance of the MOS-on-NWELL device of FIG. 1B as a function of applied voltage.
- [0012] FIG. 2A illustrates how two MOS-on-NWELL devices may be connected to act as a single capacitor with a substantially linear total capacitance as a function of the applied voltage.
- [0013] FIG. 2B shows a total capacitance of the combination of the two devices of FIG. 2A.
- [0014] FIG. 3A shows a PMOS transistor connected to act as a MOS capacitor.
- [0015] FIG. 3B shows a capacitance as a function of the applied voltage for the device of FIG. 3A.
- [0016] FIG. 4A illustrates two PMOS transistors connected in parallel to achieve a relatively flat capacitance as a function of voltage.
- [0017] FIG. 4B shows a total capacitance of the two PMOS transistors connected as in FIG. 4A.
- [0018] FIG. 5A illustrates four devices connected in parallel to achieve a substantially flat capacitance as a function of voltage.
- [0019] FIG. 5B shows a capacitance as a function of voltage for the circuit of FIG. 5A.

DETAILED DESCRIPTION OF EMBODIMENTS OF THE INVENTION

- [0020] Reference will now be made in detail to the embodiments of the present invention, examples of which are illustrated in the accompanying drawings.
- [0021] In this invention, a new method is proposed, based on MOSFET devices, of achieving a high density of capacitance with low-bias dependence and high linearity. For parallel-connected bias-dependent capacitors (such as MOSFET devices) with bias voltage V_g , the total capacitance is $C_t(V_g) = \sum C_i(V_g)$, where each C_i is a function of bias voltage that is applied to both ends. In CMOS technology, for example, a capacitor can be made with NMOS devices, PMOS devices, native-NMOS

devices, MOS on NWELL devices, MOS on PWELL devices, or any other capacitor available in that process.

[0022] To achieve a higher density of capacitors in an integrated circuit (IC) chip, MOS devices whose capacitance is based on a thin gate oxide, are the best choice. However, the MOS capacitors are highly bias-voltage dependent, which is not desirable in most applications. In this invention, different types and polarities of MOS devices are used to achieve less bias-dependent capacitors.

[0023] FIG. 1A illustrates a typical MOS-on-NWELL device 101 that may be used as a capacitor. As shown in FIG. 1A, a substrate 102 includes the NWELL. Pickup contacts (pickup terminals) 104, 106 are N⁺ doped, and are isolated from adjacent MOS devices using isolation regions 112, 113. A gate oxide layer 108 is placed above a channel region of the device (not designated in FIG. 1A). A gate electrode 110 has a voltage V_g applied to it.

[0024] FIG. 1B illustrates the single MOS-on-NWELL device 101 connected to function as a capacitor. In FIG. 1B, the pickup terminals 104, 106 of FIG. 1A are tied together. FIG. 1C illustrates a capacitance of the device 101 of FIG. 1B as a function of applied voltage V_g . The curve of FIG. 1C may be divided into three regions. A depletion region 1 is to the left of point B. An accumulation region 2 is to the right of point A. A region between A and B is a non-linear region, where the capacitance of the device depends non-linearly on the applied voltage V_g . Typically the capacitance in region 1 is roughly one third of the capacitance of region 2, although this parameter is highly process dependent. With the graph of FIG. 1C in mind, it is clear why the use of a single MOS-on-NWELL capacitor 101 is problematic in RF and analog circuits that require linearity. More specifically, the region between A and B is problematic for RF operation.

[0025] FIG. 2A illustrates how two MOS-on-NWELL devices 101 may be connected to act as a single capacitor with a substantially linear total capacitance as a function of the applied voltage V_g . As shown in FIG. 2A, one MOS-on-NWELL device 101 is connected with the polarity as shown in FIG. 1B, and a second device 101 is connected with a reverse polarity (compared to the first device). The total capacitance of the combination of the two devices 101 (one of which is operating in a depletion

region, and one in an accumulation region) is shown by the solid line **204** in **FIG. 2B**. The dashed lines **202A**, **202B** in **FIG. 2B** represent the individual $C(V_g)$ curves of the two MOS-on-NWELL devices **101**. With the devices **101** connected as shown in **FIG. 2A**, each point A has a mirror point A', and each point B has a mirror point B' relative to zero voltage. With the dashed curves adding up to the solid curve **204**, the capacitance as a function of voltage of the circuit of **FIG. 2A** is substantially flat throughout the voltage of interest, except for a small "bump" near zero voltage.

[0026] Thus, **FIG. 1A** shows an example for MOS-on-NWELL devices. **FIG. 1C** shows a C-V curve for the single MOS-on-NWELL device **101** of **FIG. 1A**. The threshold voltage of MOS-on-NWELL devices is slightly negative. Thus if two such curves are superimposed together, but one with reverse polarity, the C-V curves of **FIG. 2B** results. The C-V curve is symmetrical to $V_g=0$ and is much less sensitive to V_g . Due to the negative threshold voltage, the C-V curve shows slightly "bump" around $V_g=0$.

[0027] **FIG. 3A** shows a PMOS transistor **301** connected to act as a MOS capacitor, with its source and drain terminals tied together and to a positive voltage, and its gate tied to a negative voltage. **FIG. 3B** shows a capacitance as a function of the applied voltage for the device **301** of **FIG. 3A**.

[0028] **FIG. 4A** illustrates how two PMOS transistors **301** may be connected in parallel to achieve a relatively flat capacitance as a function of voltage V_g , which is illustrated by the solid line of **FIG. 4B**. The dashed lines of **FIG. 4B** are the individual $C(V_g)$ of the two devices **301** of **FIG. 4A**. Note that in this case, with the use of two PMOS transistors **301**, the C-V curve is relatively flat, with a slight drop around zero volts. Thus, **FIG. 3B** shows the C-V curve for a single PMOS device, and **FIG. 4B** shows the C-V curves for two parallel-connected PMOS devices with opposite polarity. The C-V curve is symmetrical to $V_g=0$ and has dip around $V_g=0$.

[0029] **FIG. 5A** illustrates how four devices, i.e., two MOS-on-NWELL devices **101** and two PMOS transistors **301** can be connected in parallel to result in a substantially flat capacitance as a function of voltage. The capacitance as a function of voltage is shown as a solid line in **FIG. 5B**, with the dashed lines representing the individual contributions from the PMOS pair and the MOS-on-NWELL pair. In this case, the

non-linearity around zero volts is even smaller (not shown to scale in this figure), since the non-linearities of the two pairs are used to substantially cancel each other out. In other words, **FIG. 5A** shows an example for the capacitance-combination of PMOS and MOS-on-NWELL devices. With optimum sizing of each device, the "dip" and "bump" can be used essentially to cancel each other, to get the flatter C-V curve of **FIG. 5B**.

[0030] With the present invention, the bias-independent capacitors can be implemented in MOS devices, which give much larger capacitance value for the same area without additional fabrication process.

Conclusion

[0031] It will be understood by those skilled in the art that various changes in form and details may be made therein without departing from the spirit and scope of the invention as defined in the appended claims. Thus, the breadth and scope of the present invention should not be limited by any of the above-described exemplary embodiments, but should be defined only in accordance with the following claims and their equivalents.